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Date: November 7, 2005

To: United States Patent and Trademark Office
Examiner: Chen, Kin Chan; Art Unit: 1765

Fax: (571) 273-8300

Re: **Application Serial No.: 10/705,347**
Filing Date: 11/8/2003; First-Named Inventor: Labelle
Attorney Docket No.: 0180151

From: Farjami & Farjami LLP

Number of pages including the cover sheet: 13

Message:

Enclosed please find the Amendment and Response to Non-Final Office Action dated August 8, 2005.

Thank you.

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Attorney Docket No.: 0180151

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Labelle, et al.

Art Unit: 1765

NOV 07 2005

Serial No.: 10/705,347

Examiner: CHEN, Kin Chan

Filing Date: November 8, 2003

For: Method for Integrating a High-K
Gate Dielectric in a Transistor
Fabrication Process

**AMENDMENT AND RESPONSE TO NON-FINAL OFFICE
ACTION**

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Non-Final* Office Action dated August 8, 2005 in the above-referenced patent application. Please enter and consider the following amendments and remarks.